

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Tsuyoshi Saito et al.

Serial No.: 09/901,577

Group Art Unit: 2132

Filed: July 11, 2001

Examiner: Derwich, Kristin M.

For: SEMICONDUCTOR MANUFACTURING APPARATUS, REMOTE CONTROL
SYSTEM THEREFOR, AND REMOTE OPERATION DEVICE

Honorable Commissioner of Patents
Alexandria, VA 22313-1450



AMENDMENT UNDER 37 C.F.R. §1.111

Sir:

In response to the Office Action dated February 8, 2006, please amend the above-identified application as follows:

INTRODUCTORY COMMENTS

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper. No new matter has been added.

Remarks begin on page 7 of this paper.